

Electronic Acknowledgement Receipt

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Application Number:	10824798
Confirmation Number:	6654
Title of Invention:	Thin-film deposition apparatus
First Named Inventor:	Hiroshi Shinriki
Customer Number:	20995
Filer:	Katsuhiro Arai/Keiko Kinoshita (KOA)
Filer Authorized By:	Katsuhiro Arai
Attorney Docket Number:	ASMJP.149AUS
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1		AmendmentAF_ASMJP-149AUS.pdf	545757	yes	12

	Multipart Description		
	Doc Desc	Start	End
	Amendment After Final	1	1
	Claims	2	6
	Applicant summary of interview with examiner	7	7
	Applicant Arguments/Remarks Made in an Amendment	8	12

Warnings:

Information:

Total Files Size (in bytes):	545757
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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.